Explanation of carrier generation & recombination process:

Carrier Generation (Prece e- and holes)

Process by which free e- and holes are generated in pair is called carrier generation In other words, when the e- in

the valence band get enough energy, they absorb the energy and jumps to conduction band. The jumped e- is called free e-2 the place from where e- is left is called hole. Similarly, two type of charge carriers (e-Sholes) are generated.

Recombination (free e- and holes)

The process by which free e- and holes gets eliminated is called recombination of carriers. When free e- in the conduction band falls into hole in the valence band, the free e- and hole gets eliminated.

e-hole pair is the fundamental unit of generation and recombination corresponding to an e-transitioning between valence band and conduction the valence band to the conduction band and recombination is a reverse process.

Recombination and generation are regulary happening in semiconductors. With the change Coulden in temperature, will increase the rate at which e- and holes are thermally generated so that their concentrations will change with time until new equilibrium values are reached an external excitation such as light can also generate e-2 holes, creating non-equilibrium condition. Letus first consider the band-to-band generation and recombination and them later on effect of allowed electronic energy states within the band-gap referred as trap brecombination are centrer

are independent of time. However e- and holes continually thermally excited from valence to continually thermally excited from valence to conduction band. At the same time, e- randomly conduction band through the crystal in the conduction band maving through the crystal in the conduction band may come near to hole I fall into the empty states in the valence band. This rate of generation I recombination should be equal:

Explanation of Carrier Generation - With the absorption of ligh energy of or increase in temperature, e- & holes when generated in pairs is known as generation process.

In the optical absorption process in semiconductors, if his Eg, then photon energy is absorbed as it has enough energy to break the covalent bond & er creates e- hole pair.

e-excitation

oe-Ev

hombe-Ev

hombe-Ev

hombe-Ev

hombe-Ev

hombe-Ev

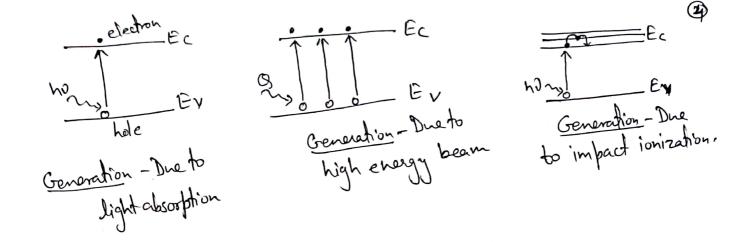
hombe-Ev

(i) Generation due to light absorption - Occurs when his is high
to excite e- from valence band till the

Conduction band giving e-hole pair. For this photon of
energy E>Eg & E-Eg is given to e-& hole in the
form of kinetic energy.

(ii) Generation due to High Energy beam - Occurs when E>> Eg (E is much greater than Eg) which gives multiple e-hole pairs. Applicable for nuclear particle country depending on semi conductors.

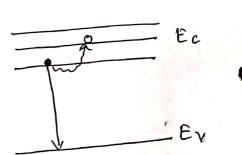
(iii) Generation due to impact ionization - due to et hole with energy much larger/smaller than conduction band valence band & edge.



Eroplanation of Recombination Process - Process due to which both carriers annihilates each other. Electrons are occupied by one or multiple steps - at the empty state associated with hole.

Kadiative Recombination

Non-Radiative Recombination.



porevious theories-

Till now, we have come to know about the e-hole pair generation. Now we will come to know about the recapturing of e with a hole.

classification:-

- i Band- to-Band recombination giving a photon (radiative)
- iii recombination by means of simply giving away energy to the phonons. (SRH-recombination)
- (iii) recombination by transferring kinetic energy to another e- and knocking out into higher energy levels. (Auger recombination)

Recombination channels Non radiative

Radiative: Direct band gap: | Photon = Eg

Indirect Band galo Photon = Eg+phonon

Electron-Auger

Phonon trap assisted, shockley-read-hall

Photon

Phonon

Phonon

electron

An indirect recombination process in which the electrons from the lower level of conduction band moves to a defect level cashich is an intermediate or transition level, lying between lower level of conduction band (Ec) and higher level of Valence band (Ev). This is followed with the photon or phonon emission. From the intermediate level they move to upper level of valence band. It shows that the flaws defects are essential for this see "SRH recombination".

This recombination process mechanism is named as SRH recombination as it was explained Shockley, Read & Hall. The defects are deep in the Crystal structure. Here, we will discuss the single level recombination.

In the fig I, under the before category and after (2) Category, the four steps are depicted.

fig (a), (b), (c), (d) are the consequences after the steps of fig 1,2,3,4 are taking place.

In fig(1), see it when the e-from Ec moves towards Et which after trapping of the to to deep level defect, e- is placed as shown in fig (a). This is step-(i).

In second step, e- from Et when goes to Ec leaves hole in Et as shown in fg(b). In step tiii) e- from Et may also move to Ev, creating hole in Et and e-hole is annihilated (destroyed) in Ev. In fourth step (iv) e- from Ev may also move to Et creating & hole in Ev and e- will be there in Et-

Step-1 is named as caputuring of e-Step-2 is known for emission of e-. In step-3 capturing of hole and in step-4 emission of hole is taking blace. In all the figures, The arrows represents The direction of pransition (fig 1, 2, 3, 4) Step(i) - Prepresents the e- capture proces from Ec (i) there is inverse of emission of e- from the centre at Et to the Ec. Step (iii) shows the capturing of hole from the valence band by the centre plantound in Et. In step (iii) the Et releases out the e-captured at that point to the valence band (Ev) captured at that point to the valence band (Ev) this step is equal to the process of transferring hole (o) from Ev to Et.

of e- from Ev creating hole in Ev. This process is equivalent to centres (Et) as if it has emilled a hole in the valence band (Ev).

is to act as an important recombination centre there must be have stephing e capture is followed by Step (iii)

Then proce step in-e-capture is followed by step (iii)
hole capture and they should have same probability,
which will nearly in going of e- from Ec to Ev.

Step (i) is followed by step (ii) which is e-emission the Et centre acts as e-toat. Similarly if step (iii) is soon followed by step (iv) then the Et centre is a hole trap. Or else the impurity level will act as recombination centre.

× ___ × ___×

Auger Recombination - Recombination with (4) three charge carriers. In this, during the e-hole pair recombination but does not emit photon or phonons, but energy is transferred to the third free e- in the conduction band. The excited e- comes back to the conduction band minimum with the release of energy in the form of heat. fig 2- duga recombination process (A non-radiative process) Process is not applicable for light doped materials. Types -Direct (Band-to-Band) (I) Indirect Auger recombination (I) Direct (Band- to-Band) diger recombinations

(e-e-h recombination) Two e- and one hole (eeth)

Ec process as shown in fig (a) In this one e- in conduction fig(a) band makes transition to the empty state hale in the valence band. The energy of e-hale pair is is bansferred to the nearly present e- and

this e- is excited to are a higher energy level in conduction band later on the excited e- comes back to thermal equilibrium with the emission of its kinetiz energy as (lattice phonons). Also possible for (e-h-h) in & which e- from conduction band recombines with hole in valence and their recombining energy is given to nearly present hole making it more to lower energy of valence band. Auger recombination is 3rd order process- (egh contd. from previous hotes).